

HSMDG22-40

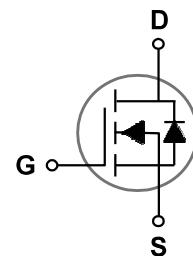
40V N Channel MOSFETs Wafer Datasheet

Features

- Die in 8" Wafer Form
- 40V , N-Channel , NGD
- $R_{DS(ON)}=2.2\text{m}\Omega$ (Max.) @ $V_{GS}=10\text{V}$

Die Description

Parameter	Parameter	Rating
Die Size (with SL)	3600 X 1900	
Gate Pad Size	180 X 180	um ²
Source Pad Size	Full Metalized Source Region	
Scribe Line Size	80	um
Wafer size	200 with 100 flat	mm
Wafer Thickness	4 (Taiko)	mil
Top Metallization	Al(4.5um) , Ni-Au(10KÅ)	
Back Metallization	NiV(3KÅ) – Ag(1.5 KÅ)	
Gate Bond Wire	1.2 mil Au or Cu x 1	
Source Bond Wire	Cu Clip or 8mil Al stitch & 7	
Estimated Gross Die	3,715	



Absolute Maximum Ratings $T_c=25^\circ\text{C}$ unless otherwise noted

Symbol	Parameter	Rating	Unit
V_{DSS}	Drain-Source Voltage	40V	V
V_{GSS}	Gate-Source Voltage	$\pm 20\text{V}$	V
T_J	Operating Junction Temperature Range	-50 to 150°C	$^\circ\text{C}$
T_{STG}	Storage Temperature Range	-50 to 150°C	$^\circ\text{C}$

Electrical Characteristics ($T_J=25^\circ\text{C}$, unless otherwise noted)

Symbol	Parameter	Conditions	Min.	Typ.	Max.	Unit
BV_{DSS}	Drain-Source Breakdown Voltage	$V_{GS}=0\text{V}$, $I_D=250\mu\text{A}$	40	---	---	V
I_{DSS}	Drain-Source Leakage Current	$V_{DS}=40\text{V}$, $V_{GS}=0\text{V}$, $T_J=25^\circ\text{C}$	---	---	1	μA
		$V_{DS}=32\text{V}$, $V_{GS}=0\text{V}$, $T_J=85^\circ\text{C}$	---	---	10	μA
I_{GSS}	Gate-Source Leakage Current	$V_{GS}=\pm 20\text{V}$, $V_{DS}=0\text{V}$	---	---	± 100	nA
$R_{DS(ON)}$	Static Drain-Source On-Resistance	$V_{GS}=10\text{V}$, $I_D=40\text{A}$	---	1.6	2.2	$\text{m}\Omega$
$V_{GS(th)}$	Gate Threshold Voltage	$V_{GS}=V_{DS}$, $I_D=250\mu\text{A}$	1.0	---	3.0	V

Note : 1. The data tested by pulsed , pulse width $\leq 300\text{us}$, duty cycle $\leq 2\%$.

2. RDS(on) calculated by PPAK5X6 Package Type , Cu Clip bond